

Advanced Wet-Cleaning Tools for Leading Edge IC Fabs

Semicon West, San Francisco July 2019



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Market Data. Information presented below in the third bullet under "Who is ACM Research?" and the first item under "Investment Highlights" contains estimates of ACM Research concerning ACM Research's total addressable markets ("TAM") that are based on industry publications, reports and customer-generated information. This information involves a number of assumptions and limitations, and you are cautioned not to rely on or give undue weight to this information. ACM Research has not independently verified the accuracy or completeness of the data contained in these publications, reports or filings. The industry in which ACM Research operates is subject to a high degree of uncertainty and risk due to variety of factors, including those described in ACM Research's public filings with the Securities and Exchange Commission, as described above.

Note Regarding Presentation of Non-GAAP Financial Measures. Information presented below under "Q1 2019 Operating Highlights" and "Q1 2019 Financial Results" includes certain "non-GAAP financial measures" as defined in Regulation G under the Securities Exchange Act of 1934, including non-GAAP gross margin, non-GAAP operating margin, non-GAAP gross profit and non-GAAP operating profit. These supplemental measures exclude the impact of stock-based compensation, which ACM Research does not believe is indicative of its core operating results. A reconciliation of each non-GAAP financial measure to the most directly comparable GAAP financial measure is included under "GAAP to Non-GAAP Reconciliation."



ACM Management and Board of Directors

ACM Management TeamDecades of Industry Experience



David Wang, CEO

Exp: Questar Tech
Ph.D. Osaka University;
BS Tsinghua University



Lisa Feng, CAO

Exp: Coherent, Amlogic
Masters: Accounting



Mark McKechnie, VP Finance Exp: Intel, Motorola, Evercore MBA Kellogg, BSEE Purdue



Jian Wang, CTO

Exp: 20+

MSc



So Cheav, VP Mfg

Exp: 25+

BSc



Fuping Chen, VP Sales

Exp: SK Hynix

MSc

Board of Directors

Average of 25+ Years Experience in Semiconductor Industry and High Tech Business



Dr. David H. Wang

ACM CEO & Founder



Dr. Haiping Dun

Engineering Director at Intel;

CEO at Champion



Prof. Chenming Hu Inventor of FinFET; Professor at UC Berkeley



Tracy Liu

Managing Partner of

H&M Int'l Accounting



Yinan Xiang
General Manger of
SSTVC



Zhengfan Yang

Director of

Sino IC



Who is ACM Research?

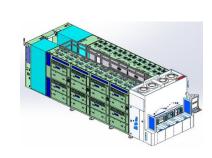
Mission Statement: To Become a Leading Global Provider of Semiconductor Capital Equipment

- Best-in-class semiconductor wafer cleaning tools providing higher yields and better efficiency at advanced fabs than conventional wafer cleaning tools
- **Differentiated megasonic technology** delivers highly effective singlewafer wet cleaning for flat and patterned wafer surfaces (SAPS) and damage-free cleaning for advanced 3D patterned wafers (TEBO)
- \$3B single-wafer wet cleaning TAM, an estimated 50% of which is addressed by current products with future expansion from new products
- More than 220 patents issued in the U.S., China, Japan, Korea, Singapore and Taiwan as of 3/31/19
- 86,000 sq. ft. across two production facilities in Shanghai offers significant capacity for growth
- Headquartered in Fremont, CA with more than 270 employees globally







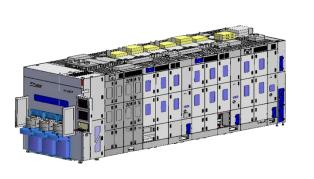


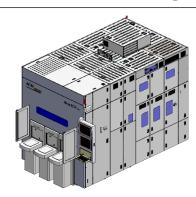
Advanced Packaging

Ultra Electrochemical Plating AP

Plating

Ultra Electrochemical Plating MAP

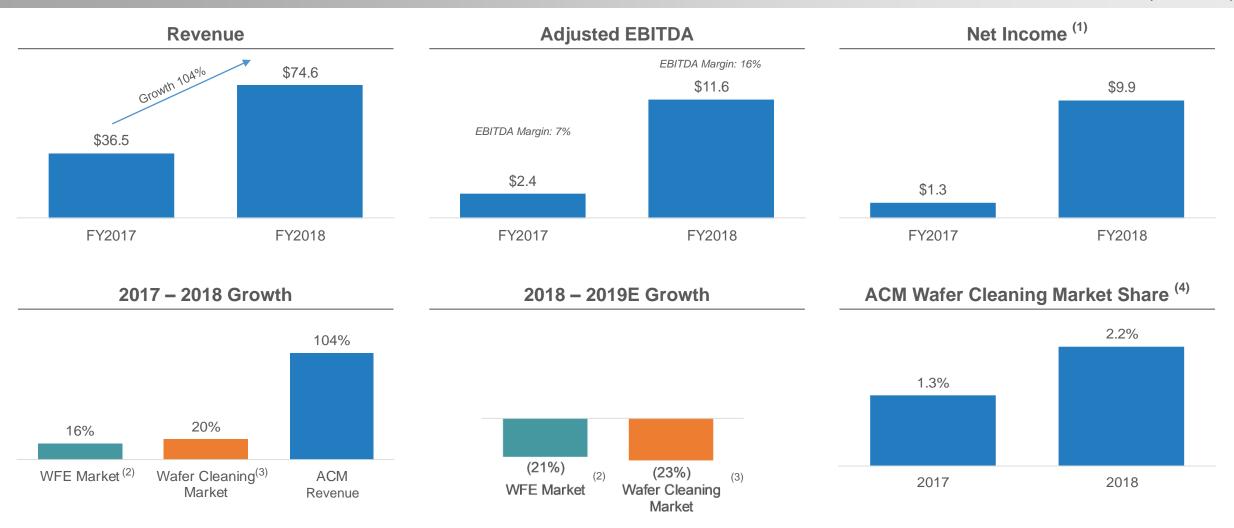






ACM is Growing at a Rapid Pace

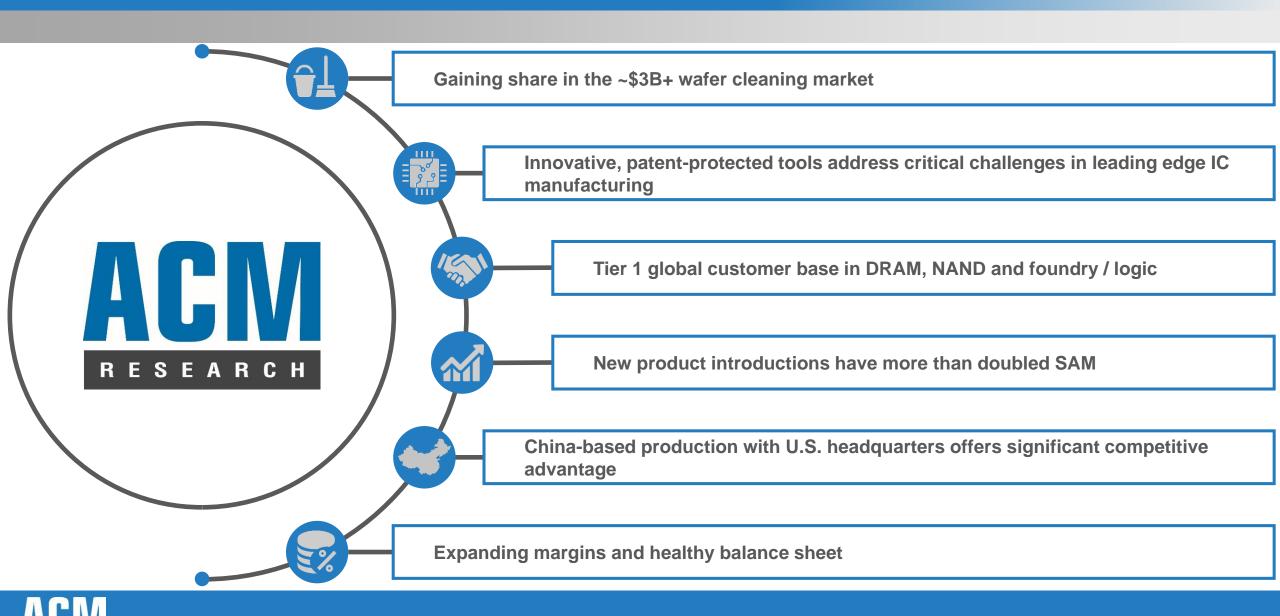
(\$ in millions)



⁽¹⁾ Based on non-GAAP net income. (2) Source: Gartner – Global Wafer Fab Equipment Market (Including Advanced Packaging). (3) Source: Gartner – Auto Wet Stations, Single-Wafer Processors and Other Clean Process markets. (4) Calculated as ACM Research revenue / Wafer Cleaning Market size in each respective year.



Investment Highlights



What is Wafer Wet Cleaning?

Wafer cleaning is a critical process in wafer fabrication that is repeated more than any other process

- Random defects arise during virtually all process steps in the wafer manufacturing process, resulting in yield loss and impaired chip performance
- Cleaning is the process of eliminating random defects on wafers
- There are two basic types of cleaning: wet cleaning and dry cleaning
- Cleaning typically occurs between other process steps (e.g., etch, deposition)

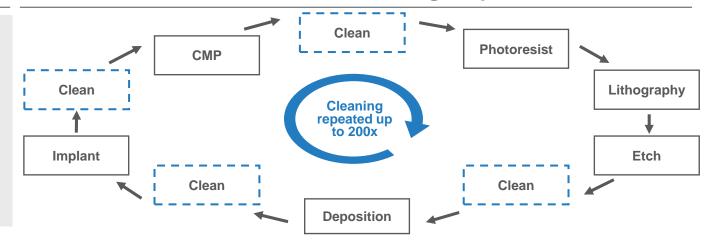
Key Benefits

- ✓Improved Yield
- ✓ Customer Satisfaction
- ✓ Reduces Costs
- ✓ Extends Moore's Law

Wet Cleaning

- Uses liquid chemistry to spray, scrub, etch and dissolve random defects
 - ► Liquid chemistries include combinations of solvents, acids and water
- More effective than dry cleaning in achieving surface cleanliness and smoothness
 - ~90% of cleaning steps in wafer fabrication

Front-End Processing Steps



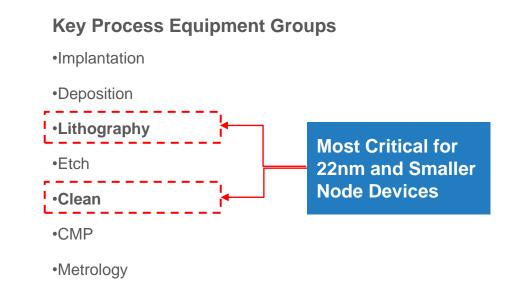


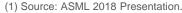
Semiconductor Roadmap Requires More Advanced Cleaning Capabilities

ACM products drive yield benefits across logic, NAND and DRAM

IC Roadmap: Transistor Shrink, FinFETs & Larger Wafers (1)

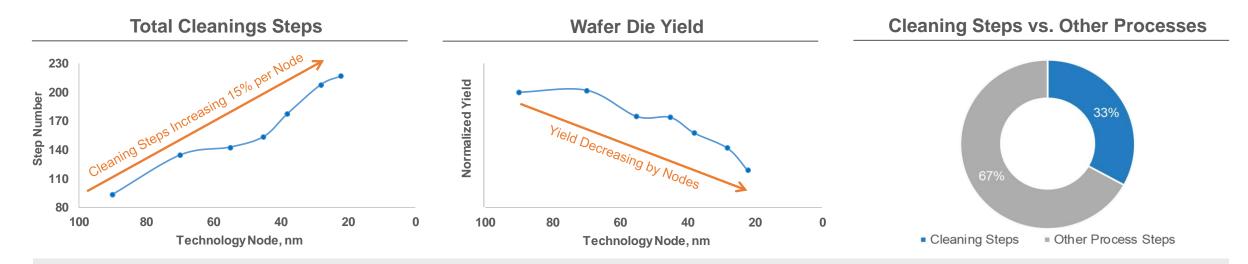








Wafer Cleaning is More Important Now Than Ever



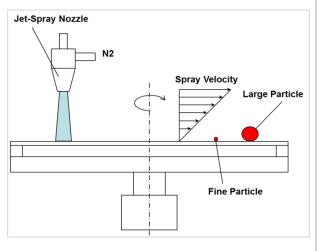
- Eliminating random defects through precise wafer cleaning steps is a critical component of the semiconductor manufacturing process
- Over the past 25 years wafer wet cleaning has become increasingly sophisticated and efficient in order to keep up with the rapid downsizing of device features
- Cleaning steps account for one third of all process steps and can be repeated up to 200 times
- 1% yield loss can lead to annual profit decrease of \$30M to \$50M (1)



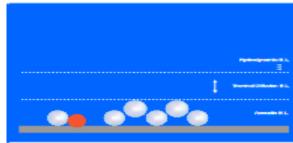


SAPS Clean Technology: Uniformly Removes Fine Particles/Defects

Single Wafer Jet-Spray Clean

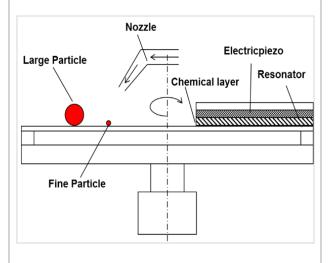


Megasonic Removes Small Particles



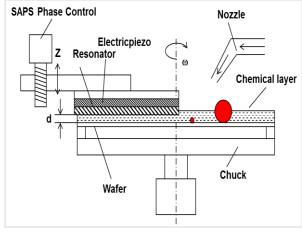
- Legacy solution offered by competitors
- Ineffective in removing small particles
- Megasonic wave creates cavitation
- Cavitation moves particle away from surface

Conventional Megasonic Clean



- Effectively removes defects below 45nm
- Challenges with warped wafers
- Damage to patterned structures

ACM Megasonic: SAPS



- Proprietary SAPS ultrasonic design
- Uniform energy delivery
- Proven results for DRAM, 3D NAND, and Foundry Processes



Tier One Customer Base



- Major new entrant into NAND flash and DRAM industry
- Expanding capacity with construction of \$24B production facility in Wuhan⁽¹⁾
- Proprietary Xtacking architecture which they are using to produce 3D NAND products⁽²⁾
- ACM 2018 Revenue %: 39% (Primarily 3D NAND)



- Leading advanced foundry in China
- Manages first fully automated 300mm wafer production line in mainland China⁽³⁾
- Production capacity for 35,000 wafers per month⁽⁴⁾
- ACM 2018 Revenue %: 24% (Primarily Foundry / Logic)



- •Global market leader in memory (DRAM & NAND) semiconductor products
- ACM's first major customer
- •Expected to spend \$107B in the coming years to build four new memory chip plants⁽⁵⁾
- •ACM 2018 Revenue %: 23% (Primarily DRAM)



- Mainland China's largest foundry
- Tier one customer base including Qualcomm, Broadcom and Texas Instruments
- Six strategically located fabs in China and Western Europe
- Building \$10B fab to produce 14nm, 10nm and 7nm chips⁽⁶⁾



- Largest bumping house in China and leading WLCSP production base
- Subsidiary of OSAT company JCET
- Owns one of the most advanced packaging technology R&D service platforms⁽⁷⁾
- Global customer base with exposure to the U.S., Western Europe and Asia



- Leading outsourced semiconductor assembly and test provider (#7 globally and #3 in China)
- Fastest growing OSAT provider globally with 32% year-over-year revenue growth⁽⁸⁾
- Recently announced creation of a joint-venture with AMD to offer differentiated assembly, test, mark and pack (ATMP) capabilities

(1) Source: Nikkei Asian Review. (2) Source: YMTC Press Release. (3) Source: HLMC Press Release. (4) Source: Reuters. (6) Source: AnandTech. (7) Source: JCAP Company Profile. (8) Source: Electronics Weekly.



Single-Wafer Wet Cleaning Products

Innovative, patent-protected tools address critical challenges in leading edge IC manufacturing

SAPS



Megasonic Cleaning for Flat and Patterned Wafer Surfaces

- √ High efficiency with enhanced process flexibility
- ✓ Uniform and consistent results
- Customizable specifications

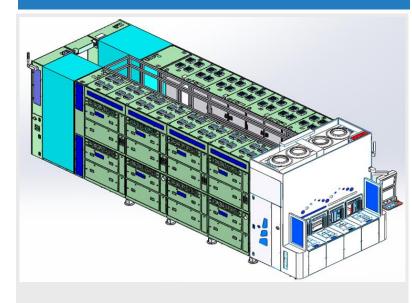
TEBO



Bubble Oscillation Cleaning for Patterned Wafers at Advanced Process Nodes

- ✓ Highly effective, damage-free solution for small and fragile features
- Multi-parameter bubble cavitation control

Ultra - C Tahoe



Hybrid Wafer Cleaning With Significant Cost & Environmental Benefits

- ✓ Environmentally-friendly with 90% less sulfuric acid used than conventional tools
- ✓ High cleaning performance at low cost



New Electrochemical Plating Products – Introduced Q1 2019

Delivers significant benefits to customers, including greater performance, increased flexibility and improved cycle times

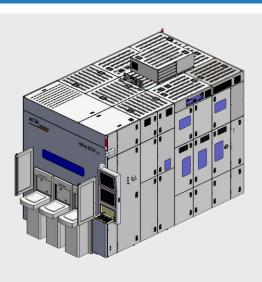
Ultra ECP AP



Advanced Wafer Level Packaging (Back-end Assembly Tool)

- ✓ Back-end assembly tool used for applying copper, tin and nickel to wafers at the die level before packaging
- ✓ Produces uniform and consistent results

Ultra ECP MAP



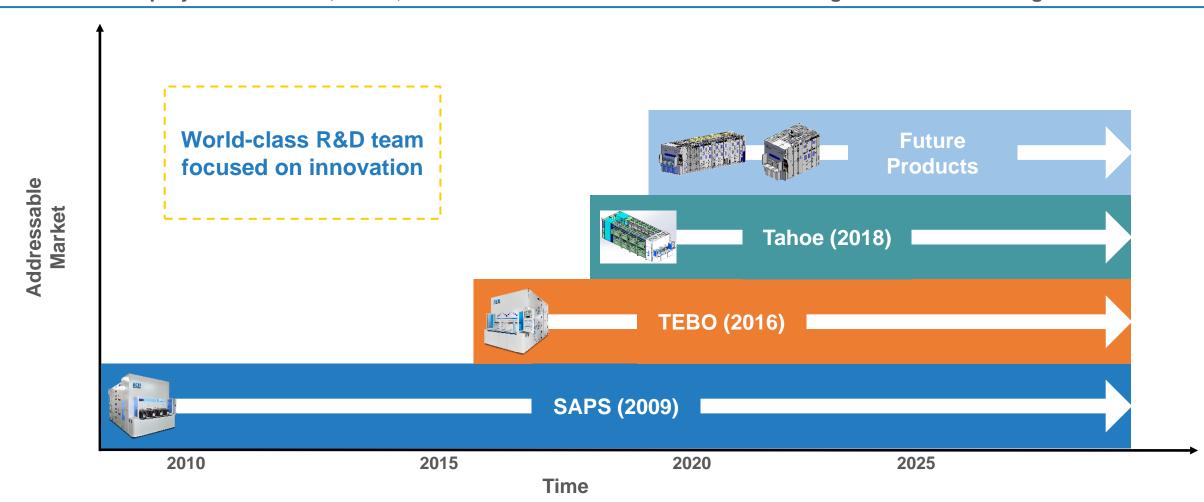
Multi Anode Partial Plating (Front-End Wafer Fabrication Processes)

- ✓ Delivers world-class electrochemical copper plating for advanced copper interconnect applications
- ✓ Offers significant performance advantages relative to competitors



Innovation and Product Introductions Expanding Addressable Market

ACM projects that SAPS, TEBO, and Tahoe address more than 50% of the single-wafer wet cleaning market



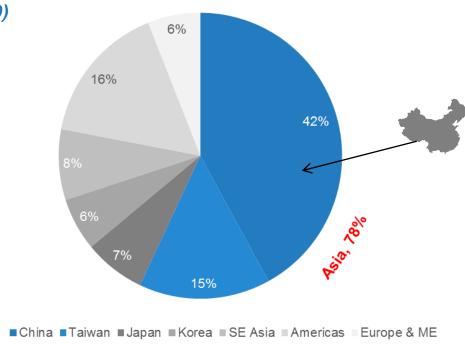


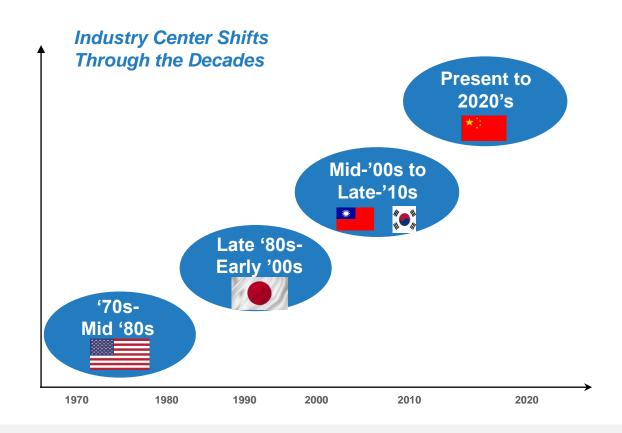
Well-Positioned to Participate in Asia Fab Investments

Semiconductor Industry Development

New Facilities and Production Lines Starting Operation

(2017-2020)







Strong presence in Asia and close proximity to Chinese customers add to key competitive advantages.

Source: World Fab Forecast Report (November 2016, SEMI).



Shanghai Manufacturing Facilities

Factory #1 (Shanghai HQ)



- Original ACM factory
- 36,000 sq. ft. facility
- 8,000 sq. ft. of class 10,000 clean room space for product assembly and testing
- 800 sq. ft. of class 1 clean room space for product demonstration purposes
- Co-located with ACM Shanghai Headquarters and China R&D Center

Shanghai Locations





Facility #2



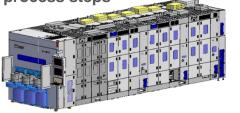
- Second factory; opened in September 2018
- 50,000 sq. ft. facility
- Shifting large portion of future production to this facility
- Additional dedicated space for product subassembly, component inventory and manufacturing related offices
- 2nd floor available for additional expansion



Growth Strategy



- Next generation TEBO and Tahoe products expand SAM in wafer clean
- Front- and back-end plating tools offer growth opportunities in adjacent process steps



Continue to Build Scale in Asia

 Continue to gain meaningful share by offering differentiated, leading edge technology and localized service with fastgrowing Asian-based customers



Add New Customers

 Megasonic approach driving meaningful engagement with Global Tier 1 foundry, logic and memory companies



Selective Acquisitions

 Use M&A to broaden product portfolio, add complementary technologies and increase access to the global market





Strategic Investment Plan – Access China's Capital Markets

- Announced on June 17th, 2019
- Plan to list shares of ACM Research (Shanghai), Inc., the principal operating subsidiary of ACM Research, on Shanghai Exchange's Sci-Tech innovAtion boaRd ("STAR Market")
 - ▶ Direct access to local capital to support China operations
 - ► Relatively attractive valuation vis-à-vis current NASDAQ trading prices for ACM Research common shares
 - ▶ Raise profile within the business and investment communities
- \$27.3 million* private placement first step to qualify for STAR Market listing
 - ▶\$23.5 million* invested from third-party investors at \$675 million* pre-money valuation
 - ▶ Potential for STAR Market premium to enable significant capital raise at just 20% dilution
- ACM Research remains committed to NASDAQ listing status and global market opportunities



Q1 2019 Operating Highlights

Business Momentum Continued Despite Near-term Industry Challenges

Solid Q1 Results

- ➤\$20.5 million revenue, up 110% from Q1 2018
- ➤43.1% GAAP gross margin and 11.0% GAAP operating margin
- ▶43.2% non-GAAP gross margin and 14.6% non-GAAP operating margin
- >\$27.4 million cash balance at March 31, 2019

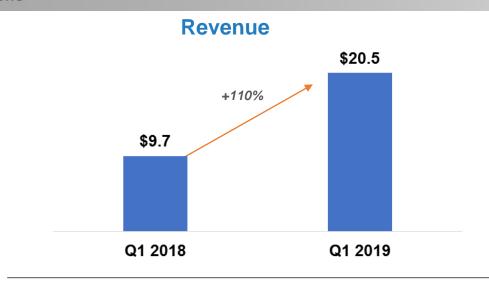
Total shipments of \$14 million in Q1 2019

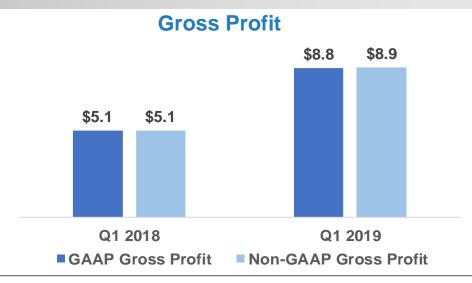
- ➤ Increase of 40% from \$10 million in Q1 2018
- Key operational progress:
 - ➤ Delivered first Ultra-C Tahoe evaluation tool
 - ➤Introduced two electro-plating products Ultra ECP AP and Ultra ECP MAP
 - ➤ Production ramp at second factory on track

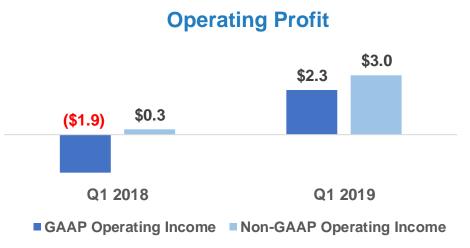


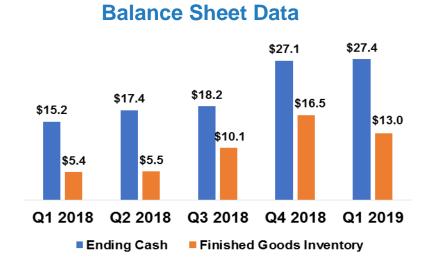
Q1'19 Financial Results

\$ Millions











Appendix – Non-GAAP to GAAP Reconciliations

	Three Months Ended March 31,													
	2019							2018						
		Actual (GAAP)		SBC	Adjusted (Non-GAAP)		Actual (GAAP)		SBC	Adjusted (Non-GAAP)				
	(0			SBC					SBC					
				(in thousands)										
Revenue		\$20,479	\$		-	\$	20,479		\$9,743	\$		-	\$	9,743
Cost of revenue		(11,653)		(3)	0)		(11,623)		(4,621)			(8)		(4,613)
Gross profit		8,826		(3)	0)		8,856		5,122			(8)		5,130
Operating expenses:														
Sales and marketing		(1,869)	7	(3-	4)		(1,835)		(1,855)		(34)		(1,821)
Research and development		(2,765)	•	(8)	6)		(2,679)		(1,541)		(27)		(1,514)
General and administrative		(1,941)	7	(59	4)		(1,347)		(3,630)		(2,1	06)		(1,524)
Income (Loss) from operations	\$	2,251	\$	(74	4)	\$	2,995	\$	(1,904)	\$	(2,1	75)	\$	271
Net income (loss)	\$	1,857	\$	(74	4)	\$	2,601	\$	(2,780)	\$	(2,1	75)	\$	(605)

